Sheet 1 of 1 JAN 1 2 2005 SERIAL NUMBER ATTY. DOCKET NO. 10/815,573 213.007-US (Modif U.S. DEPARTMENT OF COMMERCE APPLICANT(S) PATENT AND TRADEMARK OFFICE Ye et al. FILING DATE FILING DATE 1758 2825 INFORMATION DISCLOSURE STATEMENT April 1, 2004 BY APPLICANT U.S. PATENT DOCUMENTS FILING SUB NAME DATE DOCUMENT DATE CLASS CLASS BXAMINBR NUMBER Emery et al. 10/1996 5,563,702 Emery et al. 4/1998 5,737,072 POREIGN PATENT DOCUMENTS SUB CLASS DOCUMENT BXAMINBR CLASS COUNTRY DATE NUMBER INITIALS OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) "Photomask Production Integration of KLA STARlightTM 3000 System", Kalk et al, Proc. Of SPIE, Vol. 2621, 15th Annual BACUS Symposium on Photomask Technology and Management, December 1995, pp.112-121

"Defect Detection and Classification in VLSI Pattern Inspection", Soo-lk Chae, September 1987, 7 gages Ph.D. Dissertation

DATE CONSIDERED BXANINER

EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication

to applicant.

JAN 10 2005 8

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

FILING DATE GROUP ART UNIT
April 1, 2004 1758 7825

HIS	PATENT	DOCH	MENTS
U.U.	INICIAL		ATE: ATO

			TATELLI DOCUMENTS			
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
P	2004/0096883	5/2004	Fiekowsky et al.	435	6	
(De)	6,090,555	7/2000	Fiekowsky et al.	435	6	
(P)	6,397,165	5/2002	Fiekowsky	702	157	
W/	6,405,153	6/2002	Fiekowsky	702	172	
(0)	6,539,331	3/2003	Fiekowsky	702	159	
Th	6,611,767	8/2003	Fiekowsky et al.	702	19	
	6,760,473	7/2004	Fiekowsky	382	149	
(Pr)	6,765,651	7/2004	Fiekowsky et al.	355	ラ ラ	

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLAT YES/NO	
							_

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER That lake h.

DATE CONSIDERED

11/8/2015

EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.

. . ,

April 1, 2004

4758-2825

EXAMINER DOCUMENT NUMBER

DATE

NAME

CLASS

CLASS

FILING DATE

CLASS

BY APPLICANT

EXAMINER DOCUMENT NUMBER DATE COUNTRY CLASS SUB TRANSLATION YELDOO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

"Compact Formulation of Mask Error Factor for Critical Dimension Control in Optical Lithography", Zhang, et al., Microlithography, SPIE 2002, 4 pages

"A Simulation Framework for Lithography Process Monitoring and Control Using Scatterometry", Bao et al., AEC/APC 2001, 4 pages

"A Novel Approach for Modeling and Diagnostics of Lithography Process", Wang et al., AEC/APC 2001, 5 pages

"Optimum sampling for characterization of systematic variation in photolithography", Cain et al., Microlithography, SPIE 2002, 13 pages

"Electrical linewidth metrology for systematic CD variation characterization and causal analysis", Cain et al., Microlithography, SPIE 2003, 12 pages

EXAMINER Phallake Kik DATE CONSIDERED 1/18/2005

EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.

EXAMINER Phallaka Kik	DATE CONSIDERED 1/8/2005
EXAMINER: Initial citation if reference was considered. D considered. Include copy of this form with next communica	raw line through citation if not in conformance to MPEP 609 and not tion to applicant.

11 .

	A THE	<u>\$</u>				Sheet 1 of	
	PTO-1449 (Modified)	BADEMARK	ATTY. DOCKET NO.	SERIAL	SERIAL NUMBER		
	P10-1449 (Modified)*	علامتناء <u>الم</u> لك	213.007-US	10/815,573			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			APPLICANT(S)	T(S)			
INIENT	TATENT AND TRADEMARK OFFICE		Ye et al.				
INFORMATI	ON DISCLOSURE ST	TATEMENT	FILING DATE GROUP ART			700	
	BY APPLICANT		April 1, 2004	_	1750 2825		
		U.;	S. PATENT DOCUMENTS				
EXAMINER	DOCUMENT	DATE	NAME		SUB	FILING	
INITIALS	NUMBER			CLASS	CLASS	DATE	
gr	4,926,489	5/1990	Danielson et al.	332	144		
To	5,182,718	1/1993	Harafuji et al.	716	21	1	
700	5,308,991	5/1994	Kaplan	250	492.22		
(0)	5,663,893	9/1997	Wampler et al.	716	19		
(91)	5,723,233	3/1998	Garza et al.	430	5		
Je Je	5,774,222	6/1998	Maeda et al.	356	394		
P2	5,888,675	3/1999	Moore et al.	430	5		
(P)	6,077,310	6/2000	Yamamoto et al.	716	19		
Pr)	6,078,738	6/2000	Garza et al.	716	21		
(7)	6,081,659	6/2000	Garza et al.	716	21		
PI	6,120,952	9/2000	Pierrrat et al.	430	30		
TP2	6,223,139	4/2001	Wone of Wang et al.	703	5		
(1)	6,226,781	5/2001	Nistler et al.	716	19		
M	6,243,855	6/2001	Kobayashi et al.	76	19		
77	6,272,236	8/2001	Pierrrat et al.	382	144		

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO

OTHER DOCUMENTS	(Including Author, Title, Date, Pertinent Pages, Etc.)
VANUED 0/ 10/ 1/1	DATE CONSIDERED 1/8/2 COT

EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.

SERIAL NUMBER

1	PTO-1449 (Modified)	• •	ATTI BOCKET NO.	00112121		
		213.007-US		10/815,57	'3	
	ARTMENT OF COM		APPLICANT(S)			
INIDIT	AND INADDINANCE	OFFICE	Ye et al.			
INFORMATI	ON DISCLOSURE ST	FATEMENT	FILING DATE	GROUP A		
	BY APPLICANT	THE GIVEN .	April 1, 2004		-1756 282	
		U.:	S. PATENT DOCUMENTS	_Y	,	
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
(P)	6,370,679	4/2002	Chang et al.	116	19	
	6,449,749	9/2002	Stine	716	4	
	6,453,452	9/2002	Chang et al.	7/6	8	
Pr)	6,453,457	9/2002	Pierrrat et al.	716	19	
P	6,470,489	10/2002	Chang et al.	7/6	21	
01	6,519,501	2/2003	Pierrat et al.	700	121	
00	6,757,645	6/2004	Chang et al.	703	13	
(71)	2004/0225488	11/2004	Wang et al.	703	5	
		FORI	EIGN PATENT DOCUMENTS			
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YESHO
_						
	1				·	
	OTHER I	OCUMENTS (Including Author, Title, Date, Pertiner	nt Pages, Etc.)		
		1		, ,		
EXAMINER	Phallale		V. L DATE CONSIDERED	11/8/0	M	_

ATTY. DOCKET NO.